



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

LG821643767
Report verification at igi.org

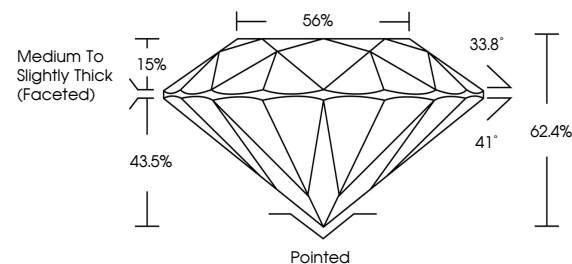
July 29, 2026	
IGI Report Number	LG821643767
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	9.23 - 9.28 X 5.77 MM
GRADING RESULTS	
Carat Weight	3.03 CARATS
Color Grade	D
Clarity Grade	VVS 2
Cut Grade	IDEAL

ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG821643767

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

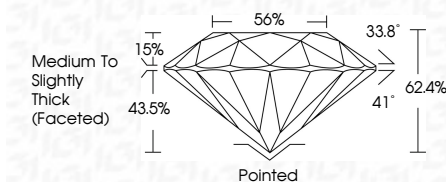
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

July 29, 2026

GI Report No LG82
DOY AND BRILLIANT

2.23 - 9.28 X 5.77 MM

Carat Weight 3.03 CARATS

D

Color Grade

Clarity Grade	WS 2	IDEAL
Out Grade		

Depth	62.4%
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	60%
able	
Girdle	Medium To Slightly

Thick (Faceted)

Culet	Pointed
Polish	EXCELLENT

EXCELLENT

Symmetry

Fluorescence	NONE
Inscription(s)	151 LG821643767

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Type IIa